



PATENT 1630-0135P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Johngeon SHIN Conf.: 9721

Appl. No.: 10/765,100 Group: 2818

Filed: January 28, 2004 Examiner: TRAN, M.

CRYSTAL GROWTH METHOD OF NITRIDE For:

SEMICONDUCTOR

LARGE ENTITY TRANSMITTAL FORM

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

April 29, 2005

Sir:

	irement in the above-identified application.
	The enclosed document is being transmitted via the Certificate of Mailing provisions of 37 C.F.R. § 1.8.
	Petition for () month(s) extension of time pursuant to 37 C.F.R. §§ 1.17 and 1.136(a). \$0.00 for the extension of time.
\boxtimes	No fee is required.
	A check in the amount of \$0.00 is enclosed.
	Please charge Deposit Account No. 02-2448 in the amount of \$0.00. A triplicate copy of this sheet is attached.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. §§1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By Just J. Jun #41,458

P.O. Box 747
Falls Church, VA 22040-0747
(703) 205-8000

JTE/SLL:sld 1630-0135P

Attachment(s)

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant:

Johngeon SHIN

Conf.:

9721

Appl. No.:

10/765,100

Group:

2818

Filed:

January 28, 2004

Examiner: TRAN, M.

For:

CRYSTAL GROWTH METHOD OF NITRIDE

SEMICONDUCTOR

REPLY TO RESTRICTION REQUIREMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

April 29, 2005

Sir:

In reply to the Restriction Requirement dated March 29, 2005, the following remarks are respectfully submitted in connection with the above-identified application.

This reply includes: Remarks.